

# ELECTRONIC INFORMATION DISCLOSURE STATEMENT

Electronic Version v18

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## Title of Invention

METHOD FOR CONTROLLING LINEWIDTH IN ADVANCED  
LITHOGRAPHY MASKS USING ELECTROCHEMISTRY

Application Number :

Confirmation Number:

First Named Applicant: Louis Kindt

Attorney Docket Number: BUR920030115US1

Art Unit:

Examiner:

Search string: ( 5780187 or 5707765 or 5935733 or 5935737 or 6139993 or 6235434 or 6309976  
or 6368762 or 6368974 or 6627362 or 20020115000 ).pn

## US Patent Documents

**Note: Applicant is not required to submit a paper copy of cited US Patent Documents**

init	Cite.No.	Patent No.	Date	Patentee	Kind	Class	Subclass
	1	5780187	1998-07-14	Pierrat et al.			
	2	5707765	1998-01-13	Chen			
	3	5935733	1999-08-10	Scott et al.			
	4	5935737	1999-08-10	Yan			
	5	6139993	2000-10-31	Lee et al.			
	6	6235434	2001-05-22	Sweeney et al.			
	7	6309976	2001-10-30	Lin et al.			
	8	6368762	2002-04-09	Ling			
	9	6368974	2002-04-09	Tsai et al.			
	10	6627362	2003-09-30	Stivers et al.			

## US Published Applications

**Note: Applicant is not required to submit a paper copy of cited US Published Applications**

init	Cite.No.	Pub. No.	Date	Applicant	Kind	Class	Subclass
	1	20020115000	2002-08-22	Gupta et al.			

## Signature

Examiner Name

Date